

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Applicants:

Date: February 14, 2008

Haight et al.

Group Art Unit: 1793

Serial No.: 09/933,461

Examiner: Geoffrey S. Evans

Filed: August 20, 2001

Docket No.: YOR919980510US2

For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF
MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)

1. This is a petition for an extension of time to respond to the Office Action dated November 2, 2007 for a period of 1 months.

2. Applicant is other than a small entity.

3. Extension:

(months)

☒ one month

☐ two months

☐ three months

Fee for other than
small entity

\$ 120.00

\$ 450.00

\$1,020.00

Fee: \$120.00

4. An Amendment

☒ is filed herewith

☐ has been filed

5. Fee payment

☒ Charge fee to Deposit Account No. 09-0468 and for any additional extension fee
required or credit any excess fee paid.

Respectfully submitted,

IBM CORPORATION
Intellectual Property Law Department
P.O. Box 218
Yorktown Heights, New York 10598

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